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2828

Docket No.: 204552021700  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Tetsuyoshi INOUE

Application No.: 09/987,010

Art Unit: 2828

Filed: November 13, 2001

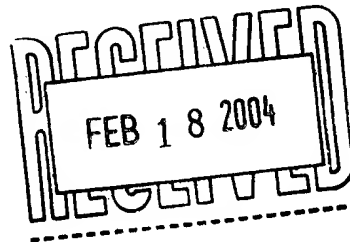
Examiner: Tuan N. Nguyen

For: SEMICONDUCTOR LASER  
MANUFACTURING METHOD AND  
SEMICONDUCTOR LASER

**AMENDMENT UNDER 37 CFR 1.116**

*MS AF*  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:



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**INTRODUCTORY COMMENTS**

This is in response to the final Office Action dated November 5, 2003. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein are respectfully requested.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.